Optical and structural characterization of nanostructured Alq₃ with negative inplane birefringence

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ABSTRACT

In this study, we investigate the optical and structural properties of tilted columnar thin films composed of Alg₃ in order to better understand the nature of the in-plane birefringence exhibited by such films. Alq3 films have demonstrated a notable absence of column broadening and secondary structural anisotropy that are commonly observed in inorganic films and also exhibit larger column tilt angles. These structural properties gave rise to optical anisotropy leading to negative values of in-plane birefringence of the films that increase with deposition angle, whereas in inorganic thin films the peak values of positive in-plane birefringence occur at deposition angles $60^{\circ} < \alpha < 70^{\circ}$. Variable angle spectroscopic ellipsometry, scanning electron microscopy, and the Bruggeman effective medium approximation description were used to characterize the films.

Keywords: glancing angle deposition, nanostructured materials, birefringence, Alq₃, ellipsometry

1 INTRODUCTION

optical properties of organic The hydroxyguinoline) aluminum (Alq₃) chiral thin films deposited at glancing angles have been a focus of interest recently due to the precise chiral (helical) architectures that may be fabricated [1, 2]. These studies have demonstrated a notable absence of column broadening and secondary structural anisotropy (asymmetric fanning of columns) commonly observed in inorganic films. In addition, strong chiral optical behaviour is observed in Alq₃ helical films, with a dependence on the deposition angle. Previous studies have shown that the magnitude of circular Bragg reflection (preferential reflection of one handedness of circular polarized light) of chiral thin films is related to the in-plane birefringence [3]. This suggests that the in-plane birefringence of tilted columnar Alq₃ films drives the chiral optical behaviour and that the birefringence should increase with the deposition angle. Such a trend is contrary to the one observed in tilted columnar inorganic thin films which tend to exhibit peak values of in-plane birefringence at deposition angles $60^{\circ} < \alpha < 70^{\circ}$ [4].

In this study, we investigate the optical and structural properties of tilted columnar thin films composed of Alq₃ in

order to better understand the source of the in-plane birefringence for films deposited using the glancing angle deposition (GLAD) technique [5]. An example of a tilted columnar film deposited at 71° is shown in Fig. 1(a). Our investigations include the use of variable angle spectroscopic ellipsometry (VASE), scanning electron microscopy (SEM), and the Bruggeman effective medium approximation (BEMA) description to determine the principal indices of refraction of tilted columnar Alq₃ films (Fig. 1(b)), as well as structural parameters such as the column tilt angle, β , and the relative film density which are used to calculate the in-plane birefringence, Δn . The in-plane birefringence is defined as:

$$\Delta n = n_x - n_p \tag{1}$$

The index of refraction in the deposition plane parallel to the substrate, n_p , is given by:

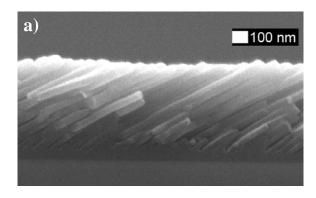
$$n_{p} = \left(\frac{\sin^{2}\beta}{n_{z}^{2}} + \frac{\cos^{2}\beta}{n_{y}^{2}}\right)^{-1/2}$$
 (2)

where n_x is the index in the substrate plane perpendicular to the deposition plane, n_y is in the deposition plane and perpendicular to the column posts, and n_z is aligned in the direction of the posts.

Knowledge of the optical parameters of Alq₃ is critical to designing and modeling of proposed nanostructured devices incorporating chiral or porous architectures such as square-spiral photonic crystals, rugate filters, and polarized light emitting devices [1, 6, 7].

2 FILM DEPOSITION

Alq₃ powder purchased from Gelest Inc. (>99% purity) was baked at 150°C for several hours under rough vacuum to remove water vapor and potential solvents. Alq₃ thin films were deposited by thermal evaporation onto silicon (100) wafers at base pressures of $< 8 \times 10^{-5}$ Pa. The deposition rate during the evaporations was monitored using a quartz crystal microbalance (QCM). Slanted columnar thin films were fabricated at various incident angles $65^{\circ} \le \alpha \le 87^{\circ}$.



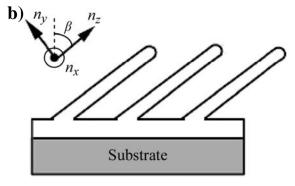


Figure 1: (a) Cross-sectional SEM image of a slanted columnar Alq₃ thin film deposited at $\alpha = 71^{\circ}$ and (b) an illustration of the corresponding principal indices of refraction.

3 OPTICAL CHARACTERIZATION

A commercial variable angle spectroscopic ellipsometer (V-VASE, J. A. Woollam Co., Inc.) was used to optically characterize the films. Optical modelling was performed using the software package supplied with the ellipsometer (WVASE32 version 3.517, J. A. Woollam Co., Inc.). The normalized Mueller matrices [8] of the films were measured over the wavelength range of 400 to 1300 nm using the V-VASE in reflection mode at light angles of incidence from 40° to 60° with respect to substrate normal.

The obliquely deposited Alq3 films were modeled using three layers on top of a silicon substrate. The first layer represented the solid layer of Alq₃ that forms prior to the growth of individual structures [1, 9]. The second layer used the BEMA to describe the biaxial slanted posts, where the two constituent media consisted of Alg₃ and void (i.e. $n_{void} = 1$, $k_{void} = 0$). Since the effective medium mixture was anisotropic, we used a BEMA that can account for the for cylindrically shaped inclusions [10], as was done in a similar study [11, 12]. The third layer consisted of a surface roughness layer in order to compensate for slight variations in column heights between individual posts. The modelling parameters consisting of the three layer thicknesses, the film density in the tilted column layer, the screening parameters describing the cylindrical inclusions, and the Euler angles θ (which in our case is synonymous with β) and ϕ which describe the column orientation with respect to the lab coordinate system were simultaneously fit using the modeling software. The Euler angle, ϕ , is the azimuthal angle that describes the orientation of the columns in the substrate plane. All of our fit results in the software were given an error bar corresponding to the 90% confidence limit, which was used to compute any error bars that appear in figures presented throughout this work.

4 RESULTS

4.1 Column Angle

The column angle values given by the BEMA modeled results are shown in Fig. 2 and are comparable to the measured values obtained from cross-sectional SEM images. The discrepancies are attributed to the accuracy of the positioning the SEM to be exactly parallel to deposition plane. The experimental values for the column angle increase with deposition angle, which is similar to the trend predicted by an expression given by Tait [13], however with a larger magnitude. This discrepancy is likely due to the fact that Tait's rule (shown in Fig. 2 for comparison) is a geometry based guideline that does not account for material specific behaviour including bulk diffusion, surface diffusion, and chemical interactions. These results contrast to the column tilt angles of most inorganic tilted columnar thin films which tend to be lower than the values predicted by Tait's rule [14]. This may suggest that the roles of diffusion and chemical interactions during the growth of tilted columnar Alq3 are significantly different from the roles of such effects during inorganic oblique angle film growth, and are currently under investigation.

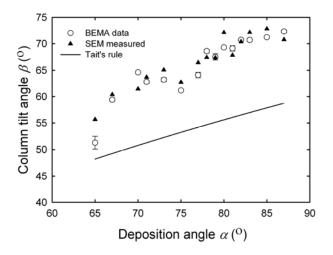


Figure 2: BEMA model and SEM measured column tilt β as a function of the deposition angle α . Tait's rule is provided as a guide.

4.2 Density and indices

Figure 3 shows the normalized density (density compared to films grown at $\alpha = 0^{\circ}$) of the biaxial post layer as a function of deposition angle measured by the optical model. As expected the film density decreases as the deposition angle is increased. This is due to increased self-shadowing that occurs at higher deposition angles, thus increasing the average spacing between nucleation sites. The result is an increase in the ratio of void to film, which decreases the effective index of refraction of the tilted column layer. The computed values for the three principal indices at a wavelength of $\lambda = 525$ nm are given in Fig. 4, and as expected, the values of the principal indices of refraction decrease with deposition angle.

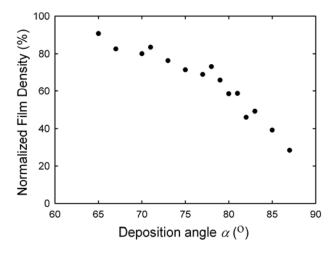


Figure 3: Normalized film density of the biaxial layer as a function of the deposition angle α .

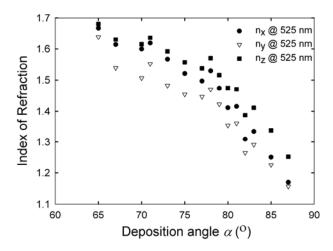


Figure 4: The principal indices of refraction for the biaxial layer of Alq₃ at a wavelength of 525 nm.

4.3 Birefringence

Figure 5 shows the calculated Δn as a function of deposition angle. A larger index of refraction in the direction parallel to the deposition plane is measured than perpendicular to the deposition plane $(n_p > n_x)$ at deposition angles $\alpha > 70^{\circ}$. This negative in-plane birefringence is opposite to the values previously seen in biaxial film studies of inorganic thin films [4, 15, 16]. A generally increasing magnitude is observed as the deposition angle α is increased, with a maximum negative birefringence of -0.073 ± 0.002 obtained for the film deposited at 85°. The negative value of the in-plane birefringence is due largely to the predominantly circular cross-section of individual Alq₃ columns in the direction of column growth, illustrated in Figure 6(a). The Alq₃ columns have diameters in the approximate range of 40 to 70 nm which remain constant throughout the thickness of the biaxial film layer and do not exhibit the common broadening effects that are present in inorganic GLAD films.

The in-plane anisotropy varies due to the form birefringence of the column cross-sections, which due to the circular nature of the post cross-sections, cause the variation of the column cross-sectional geometry in the substrate plane to vary as a function of the column tilt angle β . A greater column tilt causes an increase in the length of the major elliptical axis of the columns in the substrate plane whereas the length of the minor elliptical axis perpendicular to the deposition plane remains unchanged and equal to the post diameter.

The individual post morphology deteriorated at lower deposition angles as the individual posts began to chain together and coalesce, causing the circular cross-sections to merge and a secondary anisotropy to occur in the film perpendicular to the deposition plane as seen in Figure 6(b). This phenomenon caused a change in the form birefringence similar to column broadening seen in inorganic GLAD films, resulting in a decrease in voids between columns and thus an increase in the refractive index perpendicular to the deposition plane. This leads to the positive in-plane birefringence values observed in Figure 5 for α < 70°. The column melding effect coupled with the smaller column tilt angle reduced the negative inplane birefringence at lower deposition angles. This was observed to be largest in the films deposited at 67° and 70° which measured the largest positive birefringence values. The maximum in-plane positive birefringence occurs at a similar angle to that observed for inorganic biaxial thin films [4].

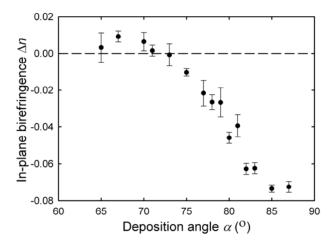


Figure 5: In-plane birefringence, Δn , shown as a function of deposition angle.

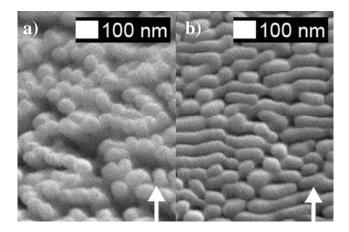


Figure 6: SEM of the film deposited at (a) $\alpha = 85^{\circ}$ and (b) $\alpha = 67^{\circ}$ as viewed along the direction of the columns. The arrows indicate the direction of the incoming vapour flux.

5 CONCLUSION

Porous biaxial thin films composed of organic Alq₃ slanted columnar posts have been fabricated and angle spectroscopic characterized using variable ellipsometry and the Bruggeman effective medium approximation. The Alq₃ films exhibited expected column angle and density behaviour in relation to the deposition angle. A negative in-plane birefringence has been observed in GLAD produced thin films with a maximum value of -0.073 ± 0.002 observed. Negative in-plane birefringence is a result of the predominantly circular cross-section of the Alg₃ columnar posts that control the form birefringence as a function of the column tilt, without the detriment of secondary anisotropic effects such as column broadening.

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